IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Hidekazu SATO, et al.

Serial Number: Not Yet Assigned

Filed: September 22, 2003

For: SEMICONDUCTOR DEVICE AND METHOD FOR MANUFACTURING THE SAME

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

September 22, 2003

Sir:

In compliance with 37 CFR 1.56, Applicants call to the attention of the Patent and Trademark Office the references listed on the attached PTO-1449.

A copy of each of the references are enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge

Deposit Account No. <u>01-2340</u>.

Respectfully submitted,

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PATENT TRADEMARK OFFICE

Enclosures: PTO-1449; References (3)

INFORMATION DISCLOSURE STATEMENT PTO-1449			Atty. Docket No. 031	Serial No. New Application				
			Applicant(s): Hidekazu SATO, et al.					
			Filing Date: September 22, 2003		Group Art Unit: Not Yet Assigned			
			U.S. PATE	NT DOCUMEN	TS			
Examiner Initial		Docum	ent No. Name	Date	Class	Subclass	Filing Date (If appropriate)	
	AA							
	AB							
	AC							
	AD				·			
			FOREIGN PA	TENT DOCUM	ENTS			
		Docum	nent No. Date	•		Translation (Yes or No)		
	AE							
	AF							
	AG							
	AH							
	AI							
			OTHER	R DOCUMENTS				
	AJ AK AL	Patent Abstracts of Japan, Publication No. 5-062991, dated March 12, 1993. K Patent Abstracts of Japan, Publication No. 10-125691, dated May 15, 1998.						
Examiner		<u> </u>	Date	e Considered				

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